Se	arch	No	tes

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/718,920	CHI ET AL.		
Examiner	Art Unit		
Andy Huynh	2818		

SEARCHED				
Class	Subclass	Date	Examiner	
257	18,19	3/30/2005	АН	
	108,178			
	179,222			
	225,254			
	417-419			
	746-748			
Text	search	3/31/2005	АН	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
257	18,19	3/30/2005	АН
	108,222		
	254,417		
257/418,747;438/50-53			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST	3/30/2005	АН	
EAST	3/31/2005	АН	
		11000	
· ·			